

## Germanium-on-silicon planar concave grating wavelength (de) multiplexers in the mid-infrared

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## Germanium-on-silicon planar concave grating wavelength (de)multiplexers in the mid-infrared

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Mid-infrared wavelength (de)multiplexers based on planar concave gratings (PCGs) fabricated on a germanium-on-silicon waveguide platform are presented. PCGs with two different types of gratings (flat facet and distributed bragg reflectors) are analyzed for both transverse electric (TE) and transverse magnetic (TM) polarizations. The insertion loss and cross talk for flat facet PCGs are found to be  $-7.6/-6.4$  dB and  $27/21$  dB for TE/TM polarization. For distributed bragg reflector PCGs the insertion loss and cross talk are found to be  $-4.9/-4.2$  dB and  $22/23$  dB for TE/TM polarization. © 2013 AIP Publishing LLC. [<http://dx.doi.org/10.1063/1.4826114>]

The mid-infrared (Mid-IR) wavelength region ( $3-12\ \mu\text{m}$ ) is of interest for sensing applications because of the strong absorption features of gases and liquids.<sup>1,2</sup> Quantum cascade lasers (QCLs) and interband cascade lasers (ICLs) enable efficient on-chip coherent Mid-IR light generation. Many detection schemes coupled with these light sources such as long path length absorption, cavity ring down spectroscopy, and photo acoustic spectroscopy have been deployed. However, in order to tap the full potential of this fingerprint wavelength region, rugged and hand-held measurement systems are needed. Integration of the Mid-IR light sources with a CMOS compatible Mid-IR waveguide platform would allow one to combine the interesting functionalities and cheap manufacturing provided by passive photonic integrated circuits and would therefore result in a complete system-on-chip which could be deployed for gas and liquid sensing applications. To cover a broad-band spectrum, distributed feedback lasers are used, which can be designed in an array, each emitting at a specific wavelength, which is tunable over a narrow wavelength range.<sup>3</sup> A very appealing component that can enable beam combining of these DFB arrays is a wavelength multiplexer. These multiplexers can also be used for separating a broadband Mid-IR spectrum in desired wavelength bands according to the requirements of the envisioned spectroscopic system. Recently, we have demonstrated wavelength (de)multiplexing in the Mid-IR ( $5.35\ \mu\text{m}$  center wavelength) on the germanium-on-silicon platform using arrayed waveguide gratings (AWG).<sup>4</sup> The insertion loss of the AWG was in the range of  $-2/-3$  dB for transverse electric (TE)/ transverse magnetic (TM) polarization, and a cross talk of  $20/16$  dB was reported for a  $5 \times 200$  GHz ( $18\ \text{nm}$  channel spacing) AWG. For wavelength multiplexers, the figure of merit is the insertion loss of the device. However, for spectroscopic applications, it is desired that the cross talk of the device is reduced as much as possible. In this letter, we present a planar concave

grating (PCG) (de)multiplexer with a much improved cross talk for both TE and TM polarization. It is known that for large channel spacing, PCGs are preferred over AWGs as the array waveguides in the AWG design start overlapping, and sophisticated changes in design have to be made while for PCGs, the length of the free propagation region (FPR) decreases for large channel spacing making the device less prone to variations in FPR layer thickness.<sup>5</sup> A PCG operating at  $3.8\ \mu\text{m}$  has been demonstrated on the silicon-on-insulator (SOI) platform,<sup>7</sup> but as the underlying oxide starts absorbing heavily beyond  $4\ \mu\text{m}$  wavelength,<sup>8</sup> a PCG fabricated in germanium-on-silicon will allow spectroscopic systems to be designed over a large fraction of the mid-infrared wavelength range given that the transparency window of silicon ranges from  $1.1\ \mu\text{m}$  to  $8\ \mu\text{m}$  and that of germanium ranges from  $1.7\ \mu\text{m}$  to  $14\ \mu\text{m}$ . Germanium-on-silicon also seems interesting for butt coupling of QCL/ICL arrays with the photonic integrated circuits because of the relative low index contrast between germanium and silicon which improves the modal overlap and hence reduces the coupling losses between QCL/ICL and the passive waveguide. Combining this with waveguide losses in the range of  $2.5-4\ \text{dB/cm}$ ,<sup>4,6</sup> the germanium-on-silicon waveguide platform becomes a compelling platform for photonic integrated circuits in the mid-infrared.

A PCG combines the functionalities of two well-known optical components: a diffraction grating to spatially separate (or combine) the wavelengths incident on it and a concave mirror to focus this light in one (or a series) of waveguides. Light is launched in a free propagating region (FPR) by an input waveguide. In the FPR, the light diffracts and hits the concave grating. The concave grating both diffracts (to spatially separate the light) and refocuses the light back in a series of output waveguides. Figure 1(a) shows a microscope picture of such a PCG, illustrating the different parts.

The design presented in this paper is based on the Rowland geometry with one stigmatic point.<sup>9</sup> Each channel's response is simulated by scalar diffraction theory.<sup>5</sup> The

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single input and six output waveguides were placed on a circle of radius  $666\ \mu\text{m}$ , and the gratings were placed on a circle of radius  $1332\ \mu\text{m}$ . The input aperture was widened to a width of  $4\ \mu\text{m}$  to launch light in the FPR and so were the output channel apertures. The channel spacing of the device was  $25\ \text{nm}$ , and the footprint of the device was  $1.5\ \text{mm}$  by  $1.2\ \text{mm}$ . The PCGs were fabricated in a  $2\ \mu\text{m}$  thick germanium layer grown on  $200\ \text{mm}$  Si(001) substrates. A metal mask was defined using *i*-line contact lithography and liftoff. Germanium etching was then carried out in a  $\text{CF}_4/\text{O}_2$  plasma in a RIE chamber. The germanium layer was completely etched through, and the devices were air clad. For characterization of the devices, we coupled light from a commercially available QCL (Daylight solutions) in a single mode Indium Fluoride fiber (IRPhotonics). The cleaved end of the fiber was mounted on a piezo-controlled xyz stage to couple into the cleaved facet of the germanium-on-silicon waveguide. The polarization at the output of the optical fiber was controlled by a Babinet-Soleil compensator between the QCL and the fiber. The output was collected from another piezo-mounted cleaved fiber and then sent to an InSb detector. To increase signal-to-noise ratio the output of the detector was coupled to a lock-in amplifier. The laser and lock-in amplifier were addressed together by software to simultaneously scan the wavelength and record the output.<sup>4</sup>

In this study, PCGs with two different grating facets were fabricated as described below.

**Flat facet grating:** In a first configuration flat germanium ( $n=4$ )/air ( $n=1$ ) interface facets were used, leading to a Fresnel power reflection coefficient (assuming perpendicular incidence) of

$$R = \left\{ \frac{n_1 - n_2}{n_1 + n_2} \right\}^2 = 0.36. \quad (1)$$

Figure 1(c) shows an image of such a fabricated flat facet grating. Figure 2(a) shows the normalized transmission of a six channel PCG for TE polarized light and Figure 2(b) shows that of TM polarized light. The normalization is carried out with respect to a straight waveguide, containing input and output taper and a straight waveguide of  $0.5\ \text{cm}$

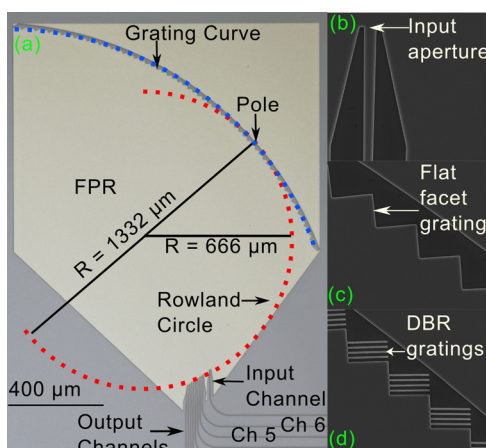


FIG. 1. (a) A microscopic image of the fabricated PCG illustrating the various parts, (b) an image of the input aperture, (c) an image of the fabricated flat facet grating, and (d) an image of the fabricated DBR facet grating.

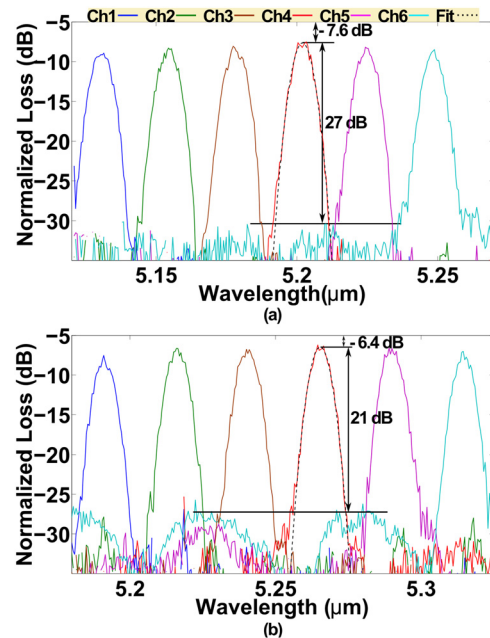


FIG. 2. Normalized spectra of a six channel PCG with flat grating facets for (a) TE polarized light and (b) TM polarized light.

length, present next to the device such that fiber-to-chip coupling losses are eliminated. The side lobe cross talk is around  $27/21\ \text{dB}$  for TE/TM polarization. To estimate the insertion loss of the device a gaussian fit of the response of the central channel for both polarizations was made. The insertion loss is  $-7.6/-6.4\ \text{dB}$  for TE/TM polarization.

The insertion loss can be largely explained by the large Fresnel reflection loss of  $-4.5\ \text{dB}$  at the flat facet. The remaining  $2-3\ \text{dB}$  loss can be attributed to the non-verticality of the grating facets and lithography imperfections such as corner rounding. Figures 3(a) and 3(b) show the normalized spectrum of the device for the TE and TM polarization, respectively, where each channel is displaced by an integer multiple of the channel spacing. It can be seen that the central lobe of the channels overlap nicely. Only the side lobes of the sixth channel are slightly worse compared to the others. This most likely comes from the fabrication imperfections of the grating facets such that they are reflecting back at wavelengths outside of the designated channel in the sixth output channel waveguide.

**DBR grating:** In the previous section we observed that although the cross talk of a six channel PCG is significantly better than the reported AWG,<sup>4</sup> the insertion loss is still higher. One way of reducing insertion loss is to increase the reflection from the grating facets. DBR gratings can be used for that purpose. Normally one would like to fabricate DBRs which reflect all the light towards the output channel waveguides. However, in fabrication we are limited to a minimum feature size of about  $1\ \mu\text{m}$  due to *i*-line contact lithography. Therefore the period of DBR gratings was chosen to be  $2.15\ \mu\text{m}$  and the fill factor 50%. An image of the fabricated DBR grating can be seen in Figure 1(d). A 2-D simulation of the reflectivity of a four period DBR grating at a wavelength of  $5.25\ \mu\text{m}$  was carried out as a function of grating period and fill factor as shown in Figure 4(a) (for TE polarized light). The schematic at the top of the figure explains the



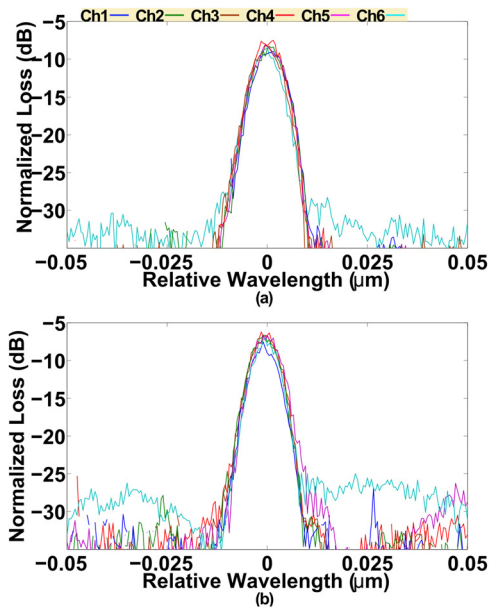


FIG. 3. Overlapped spectra of the six channel PCG with flat grating facets for (a) TE polarization and (b) TM polarization.

dimensions of the gratings, and the shaded area represents the combination of period and fill factor which will result in a minimum feature size larger than  $1 \mu\text{m}$ . Figure 4(b) shows the simulated reflection spectrum of the four period DBR grating with a period of  $2.15 \mu\text{m}$  and fill factor of 0.5 for both TE and TM polarized light in the  $4\text{--}7 \mu\text{m}$  wavelength

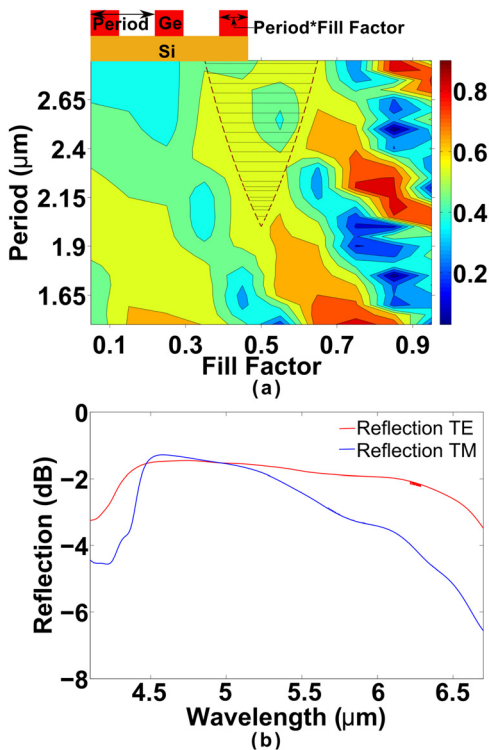


FIG. 4. (a) Simulated contour plot of reflectivity from a four period DBR grating as a function of period and fill factor. The shaded area shows the combination which can be fabricated using 1-line contact lithography and the schematic at top explains grating parameters. (b) Simulated broadband reflection spectrum of a four period DBR grating with a period of  $2.15 \mu\text{m}$  and 50% fill factor for TE and TM polarized light.

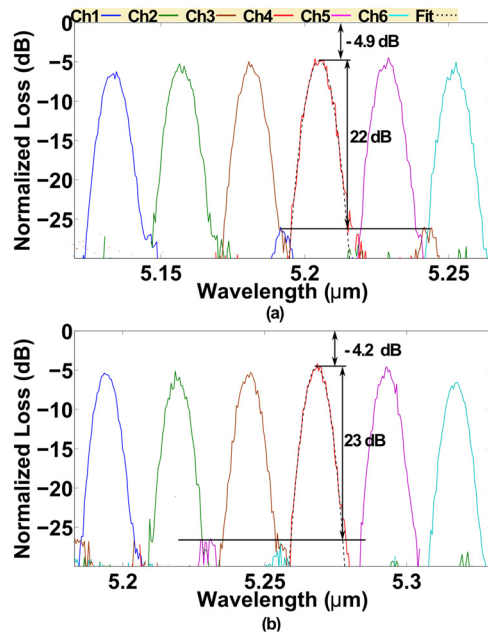


FIG. 5. Normalized spectra of a six channel PCG with DBR gratings for (a) TE polarized light and (b) TM polarized light.

range illustrating a peak reflectivity of  $-1.45\text{--}1.25 \text{ dB}$  and  $-1 \text{ dB}$  bandwidth of  $2.1/1 \mu\text{m}$  for TE/TM polarization. The insertion loss is related to out of plane diffraction losses of the third order grating and can therefore not be improved by increasing the number of grating periods. Figure 5(a) shows the normalized transmission of a six channel PCG for TE polarized light and Figure 5(b) shows that of TM polarized light. The side lobe cross talk is around 22/23 dB for TE/TM polarization. To estimate the insertion loss of the device a gaussian fit of the response of the central channel for both polarizations was made. The insertion loss is  $-4.9\text{--}4.2 \text{ dB}$  for TE/TM polarization. This clearly illustrates the insertion

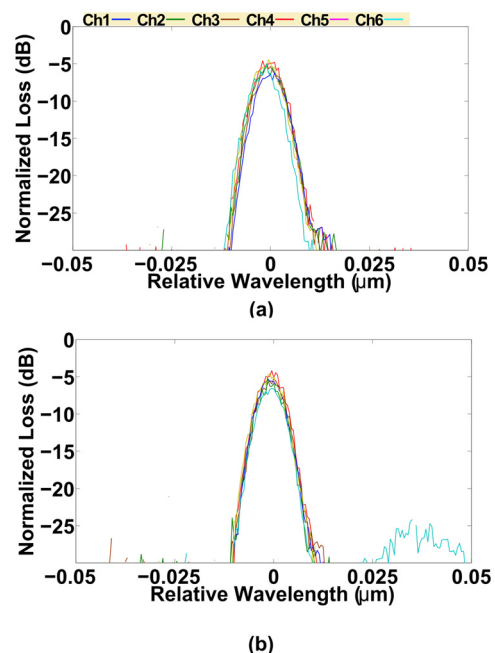


FIG. 6. Overlapped spectra of the six channel PCG with DBR gratings for (a) TE polarization and (b) TM polarization.

loss improvement of these devices by incorporating third order Bragg gratings. This result paves the way to achieving <3 dB insertion loss when highly reflective gratings are used, e.g., a period of 2.15  $\mu\text{m}$  and fill factor of 85% (320 nm spacing between grating teeth, which can be fabricated using standard CMOS tools) will result in 95% reflection as seen in Figure 4(a).

Figures 6(a) and 6(b) show the normalized spectrum of the device for TE and TM polarization, respectively, where each channel is displaced by an integer multiple of the channel spacing. Again only the sixth channel response suffers from slightly higher crosstalk similar to the case of the flat facet PCG.

In conclusion, we have demonstrated the use of germanium-on-silicon planar concave gratings as a wavelength (de)multiplexer for the mid-infrared. Although the insertion loss of the device is higher than our previously reported AWG based (de)multiplexer, the major cause for this is the lower reflection coming from the gratings, which can be substantially increased by using better performing gratings through the use of standard CMOS fabrication tools. The cross talk of these devices is comparable to PCGs fabricated on the SOI material platform at shorter wavelength in a CMOS pilot line. The integration of these devices with mid-

infrared laser sources can lead to integrated mid-infrared laser light engines for spectroscopic sensing applications.

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